



Patent
Attorney's Docket No. 015290-506

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Ting CHIEN et al.

Application No.: 09/820,692

Filed: March 30, 2001

For: PLASMA ETCHING OF DIELECTRIC
LAYER WITH SELECTIVITY TO STOP
LAYER

Group Art Unit: 1765

Examiner: K.C. Chen

Confirmation No.: 5245

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following extension of time is requested to respond to the Official Action mailed
October 7, 2003:

F E E

☒ one month to February 7, 2004 ☐ \$55.00 (2251) ☒ \$110.00 (1251)

☐ The shortened statutory period has been reset by an Advisory Action dated

☒ An extension fee in the amount of \$ 110.00 is enclosed.


☐ Charge \$ _____ to Deposit Account No. 02-4800.

The Director is hereby authorized to charge any appropriate fees under 37 C.F.R. §§ 1.16, 1.17 and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 02-4800. This paper is submitted in duplicate.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

Date: February 6, 2004

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